

FE F Docket No.: 50395-125

PATENT

FEB 1 2002  
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Kenichi KURISU

Serial No.: 09 993,223

: Group Art Unit: 1765

Filed: November 26, 2001

: Examiner: not yet assigned

For: ETCHING METHOD FOR ZnSe POLYCRYSTALLINE SUBSTRATE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits.

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No certification or fee is required.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

  
Arthur J. Steiner  
Registration No. 26,106

600 13<sup>th</sup> Street, N.W.  
Washington, DC 20005-3096  
(202) 756-8000 AJS:mlw  
**Date: February 19, 2002**  
Facsimile: (202) 756-8087